



AF/2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Gurtej Singh Sandhu et al.
Title: CHEMICAL VAPOR DEPOSITION OF TITANIUM
Docket No.: 303.676US2
Filed: August 28, 2001
Examiner: Jeff Vockrodt

Serial No.: 09/940,917
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Group Art Unit: 2822

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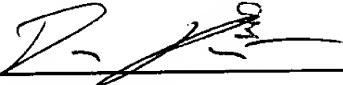
Commissioner for Patents
Washington, D.C. 20231

We are transmitting herewith the following attached items (as indicated with an "X"):

- A return postcard.
 An Amendment and Response under 37 CFR § 1.116 (10 Pages).

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Box AF, Commissioner for Patents, Washington, D.C. 20231, on this 14th day of March, 2003.

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